



LOT Vacuum started 2009 having placed its 1000th pump into Solar PV manufacturing applications. The durability and reliability of LOT process pumps make them the pump of choice for OEM's in (a-Si) TCO applications, PECVD photosensitive layers and thin films, and other coatings for front contact - TCO such as ZnO, Window Layers - CdS, Absorber - CIGS, and back contact Molybdenum. LOT pumps are also being used on other applications deposited by physical vapor deposition (PV, PVD, PE-PVD) , or sputtering by either DC, RF, AC or pulsed DC power and evaporation.